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2815

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : N. Sakamoto et al.

Art Unit : 2815

Serial No. : 09/810,101

Examiner : Sheila Clark

Filed : March 16, 2001

Title : RADIATION SUBSTRATE AND SEMICONDUCTOR MODULE

**MAIL STOP AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

PETITION FOR ONE-MONTH EXTENSION OF TIME

Pursuant to 37 CFR §1.136, applicant hereby petitions that the period for response to the action dated October 10, 2003, be extended for one month to and including February 10, 2004.

Enclosed is a check for \$110 for the required fee. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

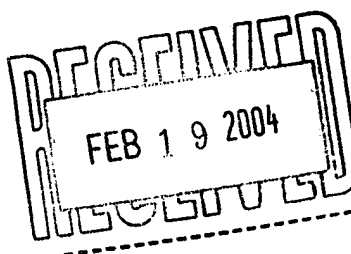
Date: \_\_\_\_\_

2/10/04

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CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

February 10, 2004

Date of Deposit

Signature

Paula T. Romeo

Typed or Printed Name of Person Signing Certificate